ELECTRICAL, STRUCTURAL, AND OPTICAL PROPERTIES OF CR-DOPED AND NON-STOICHIOMETRIC V₂O₃ THIN FILMS (POSTPRINT)

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ELECTRICAL, STRUCTURAL, AND OPTICAL PROPERTIES OF CR-DOPED AND NON-STOICHIOMETRIC V2O3 THIN FILMS (POSTPRINT)

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V2O3 films and Cr-doped V2O3 films were grown on (0 0 0 1) (C-plane) and (1 1 2 0) (A-plane) oriented sapphire substrates by the reduction of sol-gel derived vanadium oxide films. Examination by X-ray diffraction, scanning electron microscopy, transmission electron microscopy, and atomic force microscopy showed the films to be comprised of highly oriented grains. Optical transmission and resistivity measurements revealed phase transitions characteristic of the single crystal V2O3 and Cr-doped V2O3. Subsequent anneals of the un-doped films under controlled oxygen atmospheres yielded non-stoichiometric films with metal-insulator transitions characteristic of annealed V2O3 single crystals.

Phase Transitions, Vanadium Oxide, Optical Properties, Electrical Properties
Electrical, structural, and optical properties of Cr-doped and non-stoichiometric V$_2$O$_3$ thin films

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Abstract

V$_2$O$_3$ films and Cr-doped V$_2$O$_3$ films were grown on (0 0 0 1) (C-plane) and (1 1 2 0) (A-plane) oriented sapphire substrates by the reduction of sol–gel derived vanadium oxide films. Examination by X-ray diffraction, scanning electron microscopy, transmission electron microscopy, and atomic force microscopy showed the films to be comprised of highly oriented grains. Optical transmission and resistivity measurements revealed phase transitions characteristic of the single crystal V$_2$O$_3$ and Cr-doped V$_2$O$_3$. Subsequent anneals of the un-doped films under controlled oxygen atmospheres yielded non-stoichiometric films with metal-insulator transitions characteristic of annealed V$_2$O$_3$ single crystals.

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1. Introduction

A variety of crystal phases exist in the vanadium–oxygen system, a number of which display dramatic changes in electronic, magnetic, and optical properties associated with phase transitions. Among the most interesting and widely studied is vanadium sesquioxide, V$_2$O$_3$, which upon cooling from room temperature exhibits a paramagnetic metal (PM) to antiferromagnetic insulator (AFI) phase transition at about 150 K. The metal-insulator transition temperature in V$_2$O$_3$ is sensitive to applied pressure, vanadium to oxygen ratio, and dopant concentration with elements like Cr and Ti [1–7]. For single crystal V$_2$–xO$_3$, the metal-insulator transition temperature decreases with an increase in oxygen excess. In (V$_{1-x}$Cr$_x$)$_2$O$_3$, with chromium doping of $x<0.018$, the PM to AFI insulator transition temperature increases slightly with increasing chromium concentration. In addition, (V$_{1-x}$Cr$_x$)$_2$O$_3$ samples doped with chromium (0.005<$x$<0.018) exhibit a paramagnetic metal to paramagnetic insulator (PI) phase transition at higher temperature. The crystal structure of V$_2$O$_3$ is rhombohedral in the PM and PI phases and monoclinic in the AFI phase. The PM to AFI phase transition is accompanied by a cell volume change, causing crystals to fracture when thermally cycled [8]. A generalized phase diagram for V$_2$O$_3$ as a function of temperature and chromium dopant concentration, at 1 atm pressure, is shown in Fig. 1. The phase diagram was determined from measurements of single crystal (V$_{1-x}$Cr$_x$)$_2$O$_3$ samples and controlled atmosphere annealed V$_{2-x}$O$_3$ samples [6,7]. Since a hysteresis effect is encountered in resistivity measurements across the phase transition in crystals, this phase diagram depicts the results of measurements taken upon sample cooling.

In the past ten years, there have been a number of reports on the growth of thin films [9–16] and ultra-thin films [17–27] of V$_2$O$_3$ by reactive sputtering, reactive evaporation, pulsed laser deposition, and the sol–gel technique. By contrast, there are only two reports on the growth of Cr-doped V$_2$O$_3$ thin films.
[28,29], and no reports on systematically prepared non-stoichiometric V$_2$O$_3$ thin films. Schuler et al. [12] reported that for V$_2$O$_3$ films grown epitaxially on (0 0 0 1) oriented sapphire substrates by reactive evaporation, the transition is broadened by the strain induced by lattice mismatch. It was proposed that the substrate–film interaction hinders the structural transition from the rhombohedral to monoclinic lattice. For ultra-thin films, less than 30 nm in thickness [23], the metal to insulator transition is completely suppressed by the substrate–film interaction.

Although a substantial amount of work has been done to study the effect on the electronic transition of doping single crystal V$_2$O$_3$ with chromium [1,6], little has been reported for chromium doped V$_2$O$_3$ films. Greenberg and Singleton [28] reported that for sol–gel derived chromium doped thin films, the conductivity “tended toward insulating” with increased chromium concentration. Based on resistivity measurements, Piao et al. [29] reported an increase in the transition temperature with increasing chromium concentration, but attributed the absence of the higher temperature PM to PI transition to the small grain size in the sol–gel derived films.

2. Experimental details

V$_2$O$_3$ films were synthesized by heat-treating sol–gel derived vanadium oxide films in reducing atmospheres. The sol–gel films were prepared by spin-coating a solution of vanadium trisopropoxide, VO(PrO)$_3$, in isopropanol onto single crystalline, polished (0 0 0 1) (C-plane) and (1 1 2 0) (A-plane) oriented sapphire substrates. Sol–gel films were formed by the hydrolysis and condensation of neutral precursors in the ambient humidity. The films were dried at 85 °C, and the procedure was repeated to form one to nine layers. Chromium doped films were prepared by dissolving the chloride or acetylacetonate salts into isopropanol prior to the addition of the alkoxide. The amorphous, as-deposited films were then heat-treated in reducing atmospheres to obtain crystalline, 125 nm to 1250 nm thick V$_2$O$_3$ films. The vanadium oxide phases present in the annealed films depended on both the annealing atmosphere and temperature. V$_2$O$_3$ films were formed by heating the sol–gel films in a 5% hydrogen–95% argon gas mixture at 850 °C for 2 h. The non-stoichiometric films were prepared by subsequent annealing of the V$_2$O$_3$ films in a vertical quench annealing furnace equipped with an oxygen sensor. The operational details of this system have been described elsewhere [30].

The resulting films were examined by X-ray diffraction (XRD), scanning electron microscopy (SEM), transmission electron microscopy (TEM), and atomic force microscopy (AFM). The XRD data were obtained using a Siemens D500 diffractometer with Cu K$_\alpha$ radiation. JEOL 35CF, JEOL 2000FX, and Dimension 5000 microscopes were used to examine the microstructure of the films by SEM TEM, and AFM, respectively. The electrical resistance was measured using a standard four-probe technique. The optical transmission measurements were performed using a Perkin Elmer spectrometer.

3. Results and discussion

3.1. X-ray diffraction and microscopy

The X-ray diffraction patterns of 300 nm thick V$_2$O$_3$ films deposited on (0 0 0 1) and (1 1 2 0) oriented sapphire substrates are presented in Fig. 2a and b. The results suggest that the films
assume a preferred $c$-axis orientation on (0 0 0 1) oriented sapphire substrates and a preferred $a$-axis orientation on (1 1 2 0) oriented sapphire substrates. The X-ray diffraction patterns for films with thickness greater than 600 nm show the presence of other orientations, indicating a loss of preferred orientation in thicker films. In addition, it was found that preferred $a$-axis oriented V$_2$O$_3$ films could be grown on (0 0 0 1) oriented sapphire substrates by increasing the heating rates used to process the films.

Observation of the surface of a V$_2$O$_3$ film on sapphire by Scanning Electron Microscopy indicated that the film surfaces are relatively smooth. The TEM bright-field micrograph in Fig. 3 shows crystallites from a V$_2$O$_3$ thin film grown on C-sapphire at 925 °C. The sapphire substrate was ground from the reverse side of the film and remnants were transferred to a grid for examination by TEM. The V$_2$O$_3$ crystallites vary from 60 to 300 nm in diameter and are embedded in an amorphous matrix.

The surface morphology of a 300 nm thick V$_2$O$_3$ film on a (0 0 0 1) oriented sapphire substrate was examined using atomic force microscopy. The V$_2$O$_3$ film, which was grown by annealing for 2 h at 850 °C, was found to consist of grains oriented along the c-direction, consistent with the XRD results. The average grain size is about 60 nm, with a surface roughness of about 15 nm. An increase in temperature or annealing time resulted in an increase in grain size and surface roughness.

3.2. Optical and electronic properties

In Fig. 4a and b, plots of the electrical resistivity measured as a function of temperature are shown for V$_2$O$_3$ films on C and A-sapphire substrates. The metal-insulator transition occurs at a temperature of about 150 K in both films. Fig. 4c shows the metal-insulator transition for a single crystal of V$_{2-y}$O$_3$, with $y=0.000$, grown and annealed at Purdue University. The transition is slightly broadened in the films compared with the single crystal, and displays a temperature hysteresis of about 20 K. Transition broadening has been seen for other V$_2$O$_3$ films [9–16], and attributed to the strain induced by lattice mismatch. The change in resistivity at the transition temperature is about eight orders of magnitude for the single crystal, while it is about six in the films. These measurements suggest that the films are stoichiometric and that the electrical properties of the films do not differ greatly from those of the bulk material.

The optical transmittance of a V$_2$O$_3$ film on C-sapphire and A-sapphire recorded at temperatures above and below the phase transition in presented in Fig. 5. The figure shows the switching of the optical transmission from about 40% at 5 µm near room temperature to about 80% at 77 K. This is consistent with the existence of an electrical transition in the V$_2$O$_3$ films from a metal at room temperature, to an insulator below the 150 K transition. The value of the room temperature transmission is dependent upon the thickness of the film.
The electrical conductivity versus temperature for several (V\textsubscript{1−x}Cr\textsubscript{x})\textsubscript{2}O\textsubscript{3} films is given in Fig. 6a. Presented for reference, Fig. 6b is a plot, extracted from Ref. [6], depicting the changes in the electrical conductivity of chromium doped V\textsubscript{2}O\textsubscript{3} crystals as a function of temperature. It can be seen that the metal-insulator phase transition is present in chromium doped V\textsubscript{2}O\textsubscript{3} films, and that their electrical properties do not differ greatly from those found in single crystals. As in the un-doped films, the transitions are somewhat broader and the magnitude of the transitions is less than is seen in the single crystal samples.

The optical transmittance of (V\textsubscript{1−x}Cr\textsubscript{x})\textsubscript{2}O\textsubscript{3} films on C-sapphire as a function of temperature is presented in Fig. 7. The un-doped film shows a transition at 150 K from a metal with a transmission of about 7% to an insulator with a transmission of about 60%. Referring to the single crystal behavior presented in Fig. 6b, the films show a similar behavior with an increase in the low temperature metal-insulator transition temperature with increasing chromium concentration. The higher temperature transition appears in the optical transmission measurement. It is also broadened and reduced in magnitude relative to measurements on single crystals.

Fig. 8 is a plot of the optical transmission at 4 micron versus temperature for annealed, non-stoichiometric V\textsubscript{2}−\textsubscript{y}O\textsubscript{3} films. As referenced in Fig. 1, the metal-insulator transition temperature decreases with increasing non-stoichiometry. The values for y...
given in Fig. 8 have been extrapolated from transition temperatures for the data on single crystals from Ref. [7]. The transitions are again very broad and decreased in amplitude. In addition, it was found that to obtain the same transition temperature and degree of non-stoichiometry, the films must be annealed at much lower oxygen pressures than for the single crystals. It is possible that a small amount of re-oxidation occurs during the quench, which is insignificant in the bulk crystals, but is significant for the small grains in the films. From Fig. 1, it can be seen that below $y = 0.012$, the transitions occur below the 77 K temperature limit of the optical measurements.

4. Conclusions

Films with thicknesses from 125 nm to 1250 nm of $V_2O_3$ and chromium doped $V_2O_3$ films on sapphire substrates have been grown using the sol–gel method. The un-doped films were subsequently annealed under controlled oxygen atmospheres. Examination by XRD, SEM, TEM and AFM revealed that the films were comprised of well-formed, highly oriented grains. Optical transmission and resistivity measurements revealed that the films undergo phase transitions similar to those of single crystals. In comparison with the known phase diagram for the single crystal $V_2-yO_3$ and $(V_{1-x}Cr_x)2O_3$ system, it can be seen that the films exhibit a similar phase relationship. The PM to AFI transition temperature decreases from about 150 K as the vanadium to oxygen ratio is changed by annealing. The PM to AFI transition increases as the chromium concentration is increased and a higher temperature PM to PI transition appears.

References